

Reduce Cost of Cleaning Graphite Boat:

Using SunFonergy's HEC-831 cleaning agent reduced HF usage by 36%+.

Clean	Ir	nitial Dosii	ng(L)	Subsequent Dosing(L/batch)			
Graphite Boat	HF	DI	HEC-831	HF	DI	HEC-831	
Baseline	550	1250		14	/	/	
SunFonergy	350	1450	25	9	/	0.5	
Consumptio n Reduction	36.36%			35.71%			

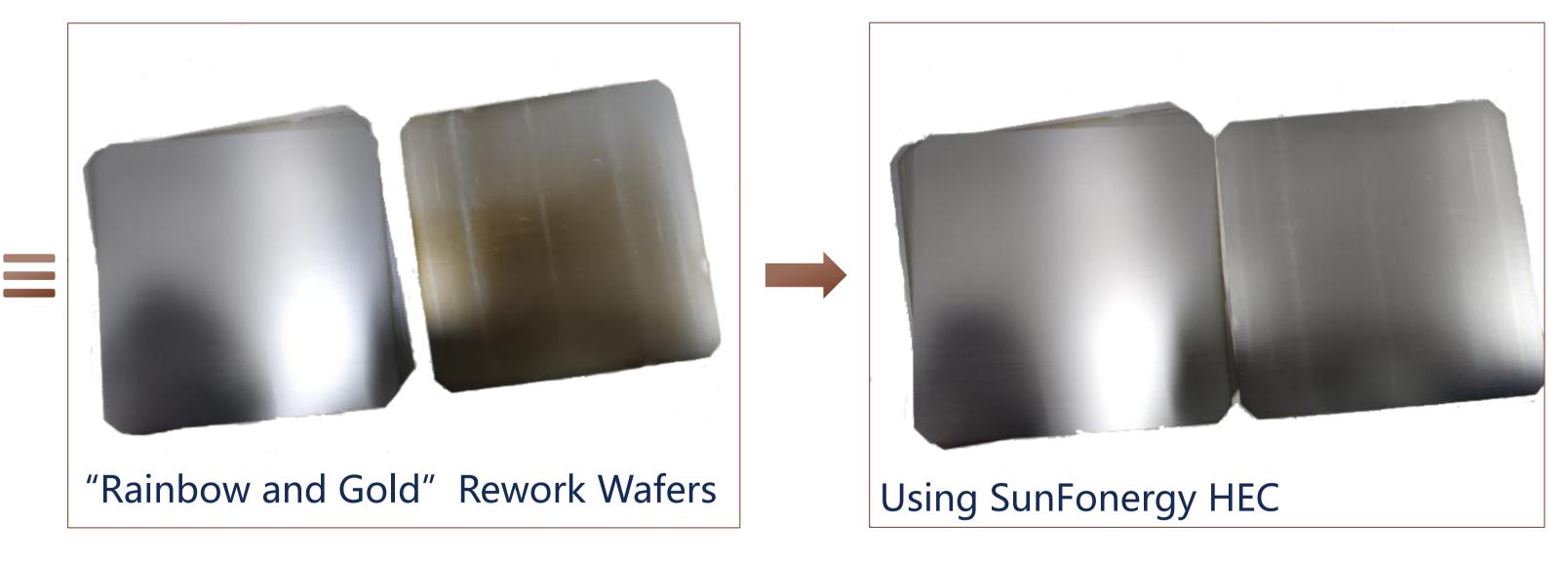
Reduce Cost of Cleaning Rework Wafer:

Using SunFonergy's HEC-831 cleaning agent reduced HF and HCl usage by ~35%-40%.

	Clean Rework Wafer	Initial Dosing(L)				Subsequent Dosing(L/batch)			
		HF	HCI	DI	HEC-831	HF	HCI	DI	HEC-831
=	Baseline	105	70	65	/	2.5	2	/	/
	SunFonergy	70	47	100	1.8	1.6	1.2	/	0.08
	Consumptio n Reduction	29%	33%			36%	40%		

Remove Rework Wafer Films:

Significantly removes = the "rainbow and gold" films on rework wafers





Reduce cost;

SunFonergy's HEC-831 significantly reduces HF and HCl usage by 35%-40%, decreasing overall production cost.



Remove "rainbow and gold" rework wafers films; HEC-831 effectively solves the problems of long process time and low productivity, and significantly removes the "rainbow and gold" films on rework wafers.